

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Rajesh Khamankar, et al.

Serial No.: 10/702,234

Filed: November 6, 2003

Title: **RELIABLE HIGH VOLTAGE GATE DIELECTRIC  
LAYERS USING A DUAL NITRIDATION PROCESS**

Grp./A.U.: 2814

Examiner: Nathan W. Ha Confirmation No. 7943

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being electronically filed  
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/Elizabeth Schumacher/  
(Signature of the person signing the certificate)

Sir:

**AMENDMENT UNDER 37 C.F.R. § 1.111**

In response to the Examiner's Action mailed March 9, 2006, please amend the above-  
identified application as follows: